IN THE UNITED STATES DISTRICT OF NEW YOR	N 4569
PLASMA PHYSICS CORPORATION and SOLAR PHYSICS CORPORATION,	
Plaintiffs, v.	) Civil Action   S/9/00 ) No S/9/00 ) JURY TRIAL
TOSHIBA CORPORATION, TOSHIBA AMERICA, INC., and TOSHIBA AMERICA ELECTRONIC COMPONENTS, INC.,	) DEMANDED ) )
Defendants.  COMPLAINT	WALL, M.J.

This complaint is filed to effectuate Judge Wexler's July 24, 2000 oral ruling with respect to Toshiba Corporation, Toshiba America, Inc., and Toshiba America Electronic Components, Inc., and Civil Action No. CV-99-8593. In accordance with Judge Wexler's ruling, the filing date of this complaint relates back to the December 28, 1999 filing date for Civil Action No. CV-99-8593 for all substantive issues in the original complaint, including damages pursuant to 35 U.S.C. § 286. Therefore, plaintiffs, Plasma Physics Corporation ("Plasma Physics") and Solar Physics Corporation ("Solar Physics"), for their separate complaint against defendants, Toshiba Corporation, Toshiba America, Inc., and Toshiba America Electronic Components, Inc., allege as follows:

## **JURISDICTION**

1. This is an action for patent infringement under the laws of the United States, Title 35, United States Code. Jurisdiction and venue are based on



Sections 1338(a), 1391(b), 1391(c), 1391(d), and/or 1400(b) of Title 28, United States Code.

### **PARTIES**

- 2. Plaintiff Plasma Physics is a New York corporation with its principal place of business at 40 Overlook Road, Locust Valley, New York 11560, within this judicial district.
- Plaintiff Solar Physics is a New York corporation with its principal place of business at 40 Overlook Road, Locust Valley, New York 11560, within this judicial district.
- Japanese corporation having a place of business at 1-1, Shibaura 1-chome, Minato-ku Tokyo, 105-8001, Japan. Upon information and belief, in connection with the acts of infringement complained of herein, Toshiba Corporation has and is (a) transacting business within New York, (b) contracting to supply goods or services in New York, (c) committing tortious acts within New York, and/or (d) committing tortious acts without New York causing injury to persons and property within New York, and (i) regularly does or solicits business, or derives substantial revenue from goods used or consumed or services rendered, in New York or (ii) expects or should reasonably expect its tortious acts to have consequences in New York and derives substantial revenue from interstate or international commerce. In addition, upon information and belief, Toshiba Corporation has and is, in connection with the acts of infringement complained of herein, purposely directing into the stream of commerce semiconductor and flat panel display components

included in Toshiba electronic products or to be included in electronic products made by others with the expectation that such electronic products will be purchased and used in New York.

- 5. Upon information and belief, defendant Toshiba America, Inc., a wholly owned subsidiary of Toshiba Corporation, is a Delaware corporation with a place of business at 1251 Avenue of the Americas, Suite 4100, New York, New York 10020, is registered to do business and is doing business in New York and has a registered agent for service of process in New York.
- 6. Upon information and belief, defendant Toshiba America Electronic Components, Inc., a wholly owned subsidiary of Toshiba Corporation, is a California corporation with a place of business at 9775 Toledo Way, Irvine, California 92618-1811, is registered to and is doing business in New York and has a registered agent for service of process in New York.

## THE PATENTS IN SUIT

7. United States Patent 4,226,897 (the "897 patent"), entitled "Method of Forming Semiconducting Materials and Barriers," duly and legally issued to Plasma Physics on October 7, 1980, based on an application filed on December 5, 1977 by John H. Coleman. Plasma Physics is the owner of title to the '897 patent and has the right to recover for past infringement thereof with respect to the following subject matter areas: apparatus for performing plasma chemical vapor coating or plasma chemical vapor etching of disc-shaped wafers made of single crystal silicon, polycrystal silicon, single crystal III-V compounds or polycrystal III-V compounds; disc-shaped wafers made with such

apparatus by plasma chemical vapor coating or plasma chemical vapor etching; and processes in combination with such apparatus (the "Excluded Subject Matter"). Solar Physics is the exclusive licensee of the '897 patent and has the right to recover for past infringement thereof in all areas except the Excluded Subject Matter.

- 8. United States Patent 5,470,784 (the "784 patent"), entitled "Method of Forming Semiconducting Materials and Barriers Using A Multiple Chamber Arrangement," duly and legally issued to Plasma Physics on November 28, 1995, based on an application filed on September 23, 1992 by John H. Coleman. Plasma Physics is the owner of title to the '784 patent and has the right to recover for past infringement thereof in the areas of the Excluded Subject Matter. Solar Physics is the exclusive licensee of the '784 patent and has the right to recover for past infringement thereof in all areas except the Excluded Subject Matter.
- 9. United States Patent 5,543,634 (the "634 patent"), entitled "Method of Forming Semiconductor Materials and Barriers," duly and legally issued to Plasma Physics on August 6, 1996, based on an application filed on June 2, 1994 by John H. Coleman. Plasma Physics is the owner of title to the '634 patent and has the right to recover for past infringement thereof in the areas of the Excluded Subject Matter. Solar Physics is the exclusive licensee of the '634 patent and has the right to recover for past infringement thereof in all areas except the Excluded Subject Matter.

#### **CLAIMS FOR PATENT INFRINGEMENT**

Upon information and belief, defendants Toshiba Corporation,Toshiba America, Inc., and Toshiba America Electronic Components, Inc. have infringed

one or more claims of the '897 and '784 patents, and are continuing to infringe one or more claims of the '784 patent, in violation of 35 U.S.C. §§ 271 (a), (b) and/or (g) by making, using, offering to sell, selling and/or importing into the United States semiconductor wafer products made by processes claimed in one or more claims of the '897 and '784 patents and/or by actively inducing infringement of one or more claims of the '897 and '784 patents. Upon information and belief, defendants Toshiba Corporation, Toshiba America, Inc., and Toshiba America Electronic Components, Inc. also have infringed and are continuing to infringe one or more claims of '634 patent in violation of 35 U.S.C. §§ 271 (a) and/or (b) by making, using, offering to sell, selling and/or importing into the United States flat panel display cells and/or modules and/or products therefrom and/or by actively inducing infringement of one or more claims of the '634 patent.

- Notice of infringement has been given to Toshiba Corporation, and thereby also to its wholly owned subsidiaries, Toshiba America, Inc., and Toshiba America Electronic Components, Inc.
- 12. Upon information and belief, Toshiba Corporation's, Toshiba America, Inc.'s, and Toshiba America Electronic Components, Inc.'s infringement has been willful and deliberate.

WHEREFORE, plaintiffs Plasma Physics Corporation and Solar Physics Corporation pray for judgment and relief against defendants, including:

A. Adjudging each of the '897, '784 and '634 patents to be not invalid and to be enforceable;

- B. Adjudging that each of the defendants has infringed and induced infringement of said patents;
- C. Permanently enjoining Toshiba Corporation, Toshiba America, Inc., and Toshiba America Electronic Components, Inc., and their officers, agents, servants, employees, attorneys, all parent and subsidiary corporations, their assigns and successors in interest, and those persons in active concert or participation with any of them who receive notice of the injunction, including distributors and customers, from continuing acts of infringement of the '784 patent;
- D. Permanently enjoining Toshiba Corporation, Toshiba America, Inc., and Toshiba America Electronic Components, Inc., their officers, agents, servants, employees, attorneys, all parent and subsidiary corporations, their assigns and successors in interest, and those persons in active concert or participation with any of them who receive notice of the injunction, including distributors and customers, from continuing acts of infringement of the '634 patent;
- E. Adjudging that an accounting be had for damages caused by the defendants' infringement, together with pre-judgment and post-judgment interest;
- F. Adjudging that defendants are willful infringers and trebling the aforesaid damages pursuant to 35 U.S.C. § 284;
- G. Adjudging that this case is an exceptional case and awarding Plasma Physics Corporation and Solar Physics Corporation their costs, expenses and reasonable attorney's fees pursuant to 35 U.S.C. § 285; and

H. Such other and further relief as this Court may deem just and

proper.

Trial by Jury is hereby demanded.

Dated: August 4, 2000

HERBERT F. SCHWARTZ (HS2599)
PATRICIA A. MARTONE (PM2989)
ERIC R. HUBBARD (EH9798)
FISH & NEAVE
1251 Avenue of the Americas
New York, New York 10020
(212) 596-9000

EDWARD F. MULLOWNEY (EM0673) MARK D. ROWLAND (MR8361) FISH & NEAVE 525 University Avenue Palo Alto, California 94301 (415) 617-4000

Attorneys for Plaintiffs,
Plasma Physics Corporation and
Solar Physics Corporation

Defendant	County of Residence
Toshiba Corporation	1-1, Shibaura 1-chome Minato-ku, Tokyo, 105-8001 JAPAN
Toshiba America, Inc.	1251 Avenue of the Americas Suite 4100 New York, NY 10020 (New York County)
Toshiba America Electronic Components, Inc.	9775 Toledo Way Irvine, CA 92618-1811

Case 0:00-cv-04569-LDW-V	DW Document 1	Filed 08/01/00	age <b>9</b> f 10 Pag	
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The JS-44 civil cover sheet and the information containe except as provided by local rules of court. This form, app of Court for the purpose of initiating the civil docket sheet	ved by the Judicial Confer	ence of the United States in t	September 1974, is require	papers as required by law, end for the use of the Clerk

I. (a) PLAINTIFFS		(OLL MOMOONOM	DEFENDANTS	THE FORMER	1
PLASMA PHYSICS CO			TOSHIBA CORPO TOSHIBA AMERI TOSHIBA AMERI		DMPONENTS, INC.
V /	OF FIRST LISTED PLAINTIFF No. PT IN U.S. PLAINTIFF CASI	assau ES)	a	N U.S. PLAINTIFF CASES DEMNATION CASES, USE TH	SEE ATTACHED ONLY) ELOCATION OF THE
Fish & Neave 1251 Avenue of t New York, NY 10 (212) 596-9000 II. BASIS OF JURISDIC  1 U.S. Government Plaintiff 2 U.S Government Defendant	MO20  PLACE AN "X" IN C  S Federal Question (U.S. Government No  □ 4 Diversity (Indicate Citizenship of in Item III)	one Box only) III. If a Party) of Parties  (PLACE AN "X" IN ON	Travis & F 377 Oak Stree Garden City,  CITIZENSHIP OF PR (For Diversity Cases Only) P: Citizen of This State  Citizen of Another State  Citizen or Subject of a Foreign Country  DUTSU	INCIPAL PARTIES PLAINT  TF DEF  1	(PLACE AN "X" IN ONE BOX FOR IFF AND ONE BOX FOR DEFENDANT)  Principal Place 1 This State 1 Another State 1 6 4 6
V. NATURE OF SUIT	vil Action 99-859 oved from □ 3 Remande a Court □ Appellate  (PLACE AN "X" IN ONE BOX	соип кеоре	another specify	district ⊓ 6 Multidistri	ct 7 Magistrate Judgment
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VII. REQUESTED IN COMPLAINT:	CHECK IF THIS IS A UNDER F.R.C.P. 23	CLASS ACTION	DEMAND \$	JURY DEM	
VIII. RELATED CASE( IF ANY	(See instructions): JUDO	GE Wexler		DOCKET NUMBER	99-8593, 00-2199, 00-3146
DATE August 4, 2000		SIGNATURE OF ATTO	RNEY OF RESORD		
FOR OFFICE USE ONLY RECEIPT #	AMOUNT	APPLYING IFP	JUDGE	MAG.	JUDGE

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# ARBITRATION CERTIFICATION

DISCLOSURE OF INT	TERESTED PARTIES - LOCAL CIVIL RULE 1. 9
	subsidiaries or affiliates of named corporate parties:
See separate statement	
Did the cause arise in Nassau or Suffoll	« County?_Yes
If you answered yes, please indicate wh	ich county. Nassau
County of residence of plaintiff(s) (1)	
County of residence of defendant(s)	(1) SEE ATTACHED (2) (3) (3)
A secondly admitted in the Ea	stern District of New York and currently a member in good
standing of the bar of this court.	
YesX	No
Are you currently the subject of	any disciplinary action(s) in this or any other state or federal o
Yes(If yes, please en	- Y
	dress and bar code below. Your bar code consist of the initials of ur digits of your social security number or any other four digit number of Court